



PATENT
Atty. Dkt. No. AMAT/5999Y1/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

~~APPROVED~~ Application of: Moon, et al

Serial No.: 10/025,144

Confirmation No.: 5051

Filed: December 18, 2001

For: Method and Apparatus for
Polishing Metal and
Dielectric Substrates

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

卷之三

Group Art Unit: 2813

Examiner: Stephen W. Smoot

CERTIFICATE UNDER 37 CFR 1.10

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on 10/28, 2003, with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV335471025US addressed to Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

10/28/2003 BZ:zfz

Date Signature

PRELIMINARY AMENDMENT

Prior to examining the above-referenced application, the Applicants request the application be amended as follows. **Amendments to the Claims** begin on page 2 of this paper. **Remarks** begin on page 10 of this paper.